N&K 之標準製程

- ♣ Substrate: Si wafer
- ♣ Substrate size: > 5cm x 5cm
- Measure thickness and N value for single layer or multiple layers
- ♣ N, K database contains : III-V compounds ; Ge compounds ; Glasses ; Nirtrides; Oxides; Oxynitrides; Silicides; Si; Si compounds.